

Laser-generated Electromagnetic Pulses

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Laser-generated electromagnetic pulses

- The interaction of high energy and high power laser pulses with matter generates a very broad band of particle and electromagnetic radiation.
- The main part of this radiation is ionizing, but there is also a significant portion which is in the radiofrequencymicrowave-terahertz frequency range.
- Transient electromagnetic pulses (EMPs) are regularly detected in laser-target interactions with laser pulses from the <u>femtosecond to the nanosecond range</u>
- Remarkable intensity (up to the MV/m order and beyond) and broad frequency range from MHz to THz.
- Recognized as a major threat to electronics, computers, diagnostics and personnel. This requires the development of effective protective measures.







- EMPs scale with laser energy and mostly with laser intensity
- The different laser pulse regimes determine different band and intensity features of the produced EMPs





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F. Consoli et al, High Power Laser Science and Engineering 8, e22 (2020)

Laser-generated electromagnetic pulses

- The new high power and high energy laser facilities that will operate at high-repetition rate require development of reliable methods of EMP detection and mitigation
- Their generation is still not very well understood. This is a very hot topics of research, since understanding of EMP physics opens to a wide number of significant applications
- One of the recognized main mechanisms of EMP generation is the creation of a potential on target, due to the fast emission of electrons.
- This potential triggers a neutralization current to ground, that can reach the kA level, showing charges up to μ C levels





F. Consoli, Philosophical Transactions of the Royal Society A -Mathematical, Physical and Engineering Science A 379: 20200022



Target polarization

- Target charging limited by two characteristic times:
 - laser pulse duration
 - cooling time of hot electrons in the target (up to ~10 ps)
- Discharge time depends instead on the size of target and stalk and on the impedance of the target support.
- In typical conditions, for a pulse duration lower than a few ps, the target charging process is temporally separated from the discharge process → charge accumulation
- Target potential defined by the temperature of hot electrons
- Charge depends on target capacitance (fractions of pF)
- Total accumulated charge varies from 10s of nC to a few μ C, depending on the laser pulse energy and duration.





J.-L. Dubois et al. Phys. Rev. E 2014⁹ A. Poyé et al. Phys. Rev. E 2015

Target polarization

- For longer laser pulses, potential is established by a balance between the rate of electron ejection and the amplitude of the return current through the stalk to the ground.
- For a reasonable stalk length, the discharge time can be estimated of the order of 100's ps and this sets the upper limit of the laser pulse duration that is prone to produce intense EMPs.
- It also explains why the problem of EMP emission is of particular importance for ps and sub-ps pulses and why it has attracted less interest in experiments with longer, ns pulses.
- Nevertheless, since EMP fields scale with both laser intensity and energy, they are still very serious and well-known threats for nanosecond high-energy and high intensity facilities.

Mechanisms of electromagnetic emission

- Emissions that are produced during the electron ejection process: during and after the laser pulse on the characteristic time of electron cooling, which is about a few ps → frequencies up to THz domain
- Generally speaking: two principal sources of EMP emission:
 - ejected electrons \rightarrow up to THz
 - neutralization current through the target stalk \rightarrow up to 100 GHz



Terahertz emission

- ps or sub-ps laser pulses \rightarrow the ejected electron bunch has millimetrical length
- THz in experiments observed with maximum in the plane perpendicular to the direction of electron emission → sheath dipolar emission
- Dipole emission produced during the electron ejection time, proportional to the second derivative of the dipolar moment *D*, significative only during the electron ejection time

Larmor Formula
$$P_E = \frac{\mu_0}{6\pi c} |\ddot{D}|^2$$
 $\mathcal{E}_{\text{THz}} \simeq \frac{Z_0}{6\pi t_{\text{ej}}} Q_e^2$

- Coherent process: total energy proportional to the square of electron charge, inversely
 proportional to the electron ejection time. Most important for the sub-ps lasers.
- Not of primary concern for electronic damage. Many possible applications.



[1] S. Herzer et al. NJP 2018; [2] A. Poyé et al. Phys. Rev. E 2018; [3] G. Liao et al. PNAS 2019; [4] J. Déchard et al Phys Plasmas 2020
[5] V.T. Tikhonchuk et al, Electromagnetic pulse generation in experiments on high power laser facilities, IVth UltraFastLight, Moscow, September 28 - October 2, 2020

Gigahertz emission

- Relaxation of the charge accumulated on the target during the laser pulse interaction
- Current pulse propagation along the holder: resonance emission of the electromagnetic pulse.
- Pulse duration defined by the target size, kA
- Small size of the target compared to the emission wavelength \rightarrow suppression of emission





• Emission is resonant \rightarrow spectrum is defined by the holder length, as a $\lambda/4$ antenna: GHz domain

$$P_E = \frac{2.44}{8\pi} Z_0 |J_{\omega_s}|^2 \qquad \mathcal{E}_{\text{GHz}} \simeq 0.1 \frac{c}{d_t} Z_0 Q_e^2$$

J.-L. Dubois et al. Phys. Rev. E 2014 A. Poyé et al. Phys. Rev. E 2015





F. Consoli et al, High Pow. Laser Sci.& Engin. 8, e22, 2020
F. Consoli et al, Phil. Trans. R. Soc. A 379, 20200022 (2020)
M. J. Mead, et al, Rev. Sci. Instr. 75, 4225 (2004).
J. E. Bateman et al Technical Report RAL-TR-2012-005
F. S. Felber , Appl. Phys. Lett. 86, 231501 (2005).
J. Krása et al Appl. Phys. Lett. 93, 191503 (2008).



target

- Deposition/secondary emission of particles on surfaces
- Transient charged layers due to photoionization
- Quasi-static electric wakefields from charges accelerated by laser-matter interaction





X-rays

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F. Consoli et al, High Pow. Laser Sci.& Engin. 8, e22, 2020
F. Consoli et al, Phil. Trans. R. Soc. A 379, 20200022 (2020)
M. J. Mead, et al, Rev. Sci. Instr. 75, 4225 (2004).
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- Deposition/secondary emission of particles on surfaces
- Transient charged layers due to photoionization
- Quasi-static electric wakefields from charges accelerated by laser-matter interaction
- Among multiple sources of this emission, we mention
 - the secondary currents induced by ejected electrons on the conducting parts of the chamber
 - emission from a toroidal current circulating in the expanding plasma plume
 - plasma recombination after the end of the laser pulse









object

F. Consoli et al, High Pow. Laser Sci.& Engin. 8, e22, 2020
F. Consoli et al, Phil. Trans. R. Soc. A 379, 20200022 (2020)
M. J. Mead, et al, Rev. Sci. Instr. 75, 4225 (2004).
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• As a result, EMP fields can have dependance not monotonically decreasing with radius and be very high also far from the interaction point

field source	distribution	intensity decreasing from	max fields	max temporal duration	max frequency range
neutralization current	vertical monopolar antenna	target $\sim r^{-lpha}$ with $lpha < 2$	Several MV m ^{—1}	100s ns	10s GHz
surface-sheath oscillations	horizontal dipolar antenna	target $\sim r^{-2}$	MV m ⁻¹	some ps	10s GHz to THz
charged layers due to photoionization	close to surfaces exposed to UV-X-γ	target and from exposed surfaces	MV m ⁻¹	some ns	10s GHz
wakefields of accelerated charges	close to the charged particle beams	charged particle beams and target	\sim MV m ⁻¹	10s ns	100s GHz
particles on surfaces	close to surfaces, even far from the target	exposed surfaces and target	MV m ⁻¹	10s ns	approximately 10s MHz to GHz



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F. Consoli, et al, Phil. Trans. Royal Soc. A 379: 20200022 (2021)

EMP distribution

- Experimental chamber: electromagnetic resonator with several sources: duration much longher than the neutralization current
- Electromagnetic modal expansion, with solenoidal eigenvectors, harmonic and irrotational electric and magnetic eigenvectors. $E = \sum_{i=1}^{+\infty} A_i E_i + \sum_{i=1}^{M-1} A_i^0 E_i^0 + \sum_{i=1}^{+\infty} B_i s_i$

$$\mathbf{E} = \sum_{i=1}^{A_i} A_i \mathbf{E}_i + \sum_{i=1}^{A_i} A_i \mathbf{E}_i^- + \sum_{i=1}^{B_i} B_i \mathbf{s}_i,$$
$$\mathbf{H} = \sum_{i=1}^{+\infty} C_i \mathbf{H}_i + \sum_{i=1}^{P-1} C_i^0 \mathbf{H}_i^0 + \sum_{i=1}^{+\infty} D_i \mathbf{g}_i,$$



Both time-domain and frequency-domain measurements and numerical simulations needed for the EMP field description



F. Consoli et al, High Pow. Laser Sci.& Engin. 8, e22, 2020 F. Consoli et al. Physics Procedia, 62, 11 (2015).

EMP distribution

- The modal structure of the electromagnetic fields is also modified by hot electrons and plasma expanding from the target.
- They move and fill the experimental chamber, influencing the space and time characteristics of transmitted and reflected electromagnetic waves.
- They may reflect EMP waves with wavelengths longer than the critical wavelength associated with the electron density.
- Thus, within the experimental chamber, a time-varying volumetric distribution of critical regions may be created for each EMP wavelength.
- Detailed analysis requires extended numerical simulations.



J. Krása, F. Consoli, et al PPCF 62, 025021 (2020) F. Consoli et al Phil. Trans. R. Soc. A 379, 20200022 (2020)

EMP distribution

- Several 'doors' lead to the transfer of the EMPs present within the chamber to the outside: dielectric glass windows, vacuum flanges, dialectric vacuum feedthroughs for coaxial cables...
- EMP also propagate upstream along the tubes of laser guide and may affect the beam pointing and compression
- Study at <u>ELI-Beamlines</u> on EMP tube propagation with ANSYS modeler



F. Consoli et al, High Pow. Laser Sci.& Engin. 8, e22, 2020;

Methods of EMP diagnostics

- **Challenges of measuring EMP fields in laser-matter interaction experiments**
- Many possible spourious effects on the field measurement and determination

Antennas

CONNECTED5000



Functional scheme of contributions for the stored signal in EMP

 s_0 EMP signal, s_3 signal actually stored in the oscilloscope

$$s_3(t) = s_2(t) + n_1(t) + n_2(t) + n_3(t) + n_4(t)$$

$$= h_{\rm TL}(t) \circledast [s_0(t) + n_0(t)] + n_{\rm ext}(t),$$

 $n_{\text{ext}}(t) = n_1(t) + n_2(t) + n_3(t) + n_4(t)$

- n_o: noise on the detector because of ionizing radiation
- n₁: EMP noise penetrating the whole transmission link
- n₃: direct coupling of EMP fields with the scope
- n_{4} : noise on the scope due to currents flowing on the outer conductor of the cables



measurements.

F. Consoli et al, High Pow. Laser Sci.& Engin. 8, e22, 2020 F. Consoli et al, PPCF 2018

PALS campaign at 600 J Energy, 1 omega #45948 - Solid Graphite - 372 J - 1.14e16 W/cm²

Superwideband Antenna (Inside Chamber)

Methods of EMP diagnostics

Coonductive Probes

- B-Dot, Moebious loops, for magnetic fields
- D-Dot for electric field
- Calibrated loops for neutralization current
- Antennas
- Main issue: information on EMPs is in terms of electrical current, in environments heavily affected by ionizing radiation → difficult measurements
- Sensitive to the time derivative of fields: low noise amplified in signal riconstruction
- Problems of electromagnetic coupling to the conductors nearby









B-DOT - PETAL



Wideband omnidirectional and monopolar antennas - ABC





Methods of EMP diagnostics

Dielectric probes

- Linear electro-optic (Pockels) effect in dielectric crystals for E field measurements, Faraday effect for B field
- Direct access to the field, rather than to its derivative
- High selectivity of field components
- High spatial resolution
- Pigtailed or open schemes
- KDP, ZnTE or Bi₁₂SiO₂₀ (BSO) cristals
- High frequency band, up to the THz level
- Sensitivity and bandwidth issues



F. Consoli et al, Sci. Rep. 2016 T. Robinson et al, Sci. Rep 2017 S. Herzer et al. NJP 2018 R. Pompili et al, Sci. Rep 2016



ABC configuration





Methods of EMP mitigation: target & interaction

• EMPs

- Increase with laser energy
- Decrease for longer laser pulses
- Increase for larger targets

• Campaigns at Vulcan and Orion, up to 500 J and up to 10²¹ W/cm²









Methods of EMP mitigation: holder

- Shape and material of the holder may reduce the EMP emission of a large extent
- High resistivity and specific impedance of the stalk can have notable results
- Spiral plastic stalks got a reduction of a <u>factor of 5</u> on the EMP intensity
- Conductive spiral holders may also reduce EMPs of about a <u>factor of 2</u>
- Levitating targets reduced EMPs of ~ <u>a factor of 25</u>, experiments on ps laser pulses



P. Bradford et al, High Power Laser Science & Engin. 2018; F. Consoli et al, High Power Laser Science & Engin. 2020; D.F.G. Minnenna, Phys. Plasmas 27, 063102 (2020); C. J. Price, Rev. Sci. Instrum. 86, 033502 (2015).

Methods of EMP mitigation: holder

- Advanced holder: resistive capillary and magnetic material
- Reduce the discharge current intensity and EMP amplitude
- Guide the target charge to the ground through the holder
- Experiments at LULI (80 J/1.3 ps) about a <u>factor of 3</u> reduction with respect to conductive holder
- Experiments at PETAL confirmed the LULI results



(a)

35

M. Bardon et al, Phy. Rev. Reses. 2, 033502 (2020)

Methods of EMP mitigation: joint nano+pico

- Recent experiments with both LMJ and PETAL showed very high EMP reduction (~5)
- Explained by PETAL target screening in the low density plasma created by the X-ray emission from the LMJ target in the residual gas around the PETAL target
- Effect depending on delays between LMJ and PETAL: observed for <20ns delays



X-ray energy 3 kJ Energy of photons 100 eV Residual gas density 5×10-6 mbar Plasma density 7×10¹¹ cm⁻³ Plasma frequency 7.5 GHz





Methods of EMP mitigation: target caging

- EMP fields confined within a Faraday cage built around the target: «birdhouse».
- The intense current must be dissipated by the target holder
- Experiments at IPPLM (330 mJ, 50 fs)





J.-L. Dubois et al. RSI 2018

Methods of EMP mitigation: EMP absorption

- Study at ELI-Beamlines on EMP tube propagation with ANSYS modeler
- The use of suitable radiofrequency-microwave absorbers can reduce the field propagation of more than a factor of 1000





Table 4. EMP energy flow at the selected ports during 1 µs calculation in percentage of initial EMP energy for different absorbers. See text for explanation of abbreviations.

Port	P1	P2	P3	P4	P2-BR
	IChAux	IChL4	LDiag	L4 compr	BackRef
No Abs	16.8	48.1	6.6	2.06	20.3
TME	15.6	50.9	0.16	0.034	2.7
P3ICh	0.45	0.42	0.071	0.025	0.28
Both	0.47	0.45	0.002	0.001	0.066

F. Consoli et al, High Pow. Laser Sci.& Engin. 8, e22, 2020

• Source comphrehension may allow for optimized EMC techniques for device and diagnostics survival and correct operation and for personnel security.





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Laser-generated electromagnetic fields

- Research activity on laser-generated electromagnetic fields is mainly for
 - Minimization and prevention of these intense fields
 - Applications
 - Strong transient magnetic fields (kT order and beyond)
 - Proton acceleration by tailored traveling waves
 - Source of THz radiation of unmatched features and intensity

a





J. Santos et al. New J. Phys. 17, 083051 (2015) S. Fujioka et al. Sci. Rep. 3, 1170 (2013) P Bradford et al PPCF 63 084008 (2021); M. Murakami et al Sci Rep 10, 16653 (2020). S. Kar et al. Nat. Commun. 7, 10792 (2016).





EMP Applications

- The understanding of the further sources of EMPs may extend the number of potential applications: material science, avionics, aerospace, electronics, medical and biological studies, electromagnetic compatibility (EMC), sensing.
- The technology can be also easily integrated in advanced schemes for particle acceleration, for particle-beam manipulation of unmatched quality, by laser and not.
- ENEA has proposed schemes for laser-generation of EM fields. ENEA Patent « A method of generating high-intensity electromagnetic fields » <u>PCT/IB2020/057464</u>, <u>WO2021/024226</u>.



EMP growing community



- A growing international community has been set up on the topic of radiofrequency-microwave field generation
- <u>Laserlab-Europe AISBL</u>, an Interest/Expert group has been created on «Laser-generated electromagnetic pulses», coordinated by ENEA (F. Consoli), with more than 20 Institutions.



EMP growing community



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- Review paper with contributions of the main laboratories on High Power Laser Science and Engineering, selected for the volume cover, got the Editor-in-Chief Choice Award 2020, and the Excellent Article for the 10th Anniversary of HPLSE Journal

High Power Laser Science and Engineering, (2020), Vol. 8, e22, 59 pages. doi:10.1017/hpl.2020.13



REVIEW

Laser produced electromagnetic pulses: generation, detection and mitigation

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> F. Consoli et al, High Power Laser Science & Engin. 2020 F. Consoli et al, Phil. Trans. R. Soc. A 2020



Conclusions

- Laser-matter interaction of high energy and intensity produce remarkable transient electromagnetic pulses, which presents a threat for electronics and personnel and have to be mitigated.
- Picosecond and sub-ps laser pulses charge the targets to a few µC and excite strong broadband electromagnetic emissions with amplitude up to the MV/m order.
- Recognized major source of emission in the GHz domain is the neutralization current flowing through the target holder generating.
- Other sources of EMP are identified, but further characterization is needed.
- Minimization is possible, and it considers both source suppression and EMC optimized techniques.
- A large number of further promising applications can be enabled by a full comprehension of the physics of EMP generation, of the mechanisms of their operation, and by a suitable characterization of EMP fields.



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Gigahertz emission

- Why the ps laser pulses are much stronger emitters in the GHz domain, compared to the ns pulses? → fs-ps pulses accumulate a big charge for a short period of time and discharge it in a short and intense current pulse
- ns pulses
 - potential is established by a balance between the rate of electron ejection and the amplitude of the return current through the stalk to the ground.
 - relatively weak continuous current induced \rightarrow much weaker emission.
 - nevertheless, remarkable and very dangerous values of EMPs are observed for nanosecond high-energy and high intensity facilities.



F. Consoli et al, PPCF 60 (2018) 105006

• The EMP signal can be significantly enhanced if a long and a short laser pulses interact with the same target.

F. Consoli et al, High Power Laser Science and Engineering 8, e22 (2020)